



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 9, 2026	
IGI Report Number	LG833656959
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	6.85 X 4.77 X 3.00 MM

GRADING RESULTS

Carat Weight	1.00 CARAT
Color Grade	F
Clarity Grade	VVS 2

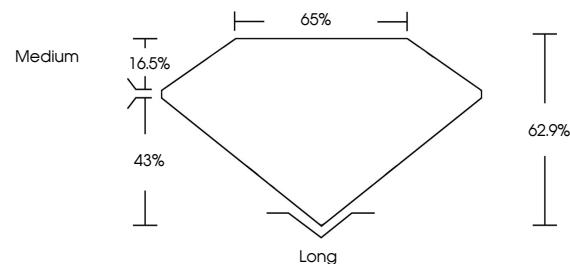
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG833656959

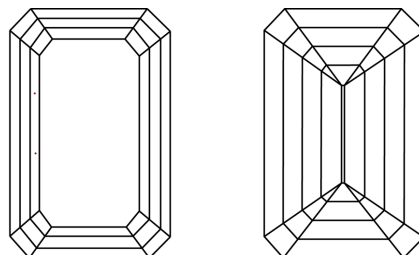
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG833656959
Report verification at igi.org

PROPORTIONS

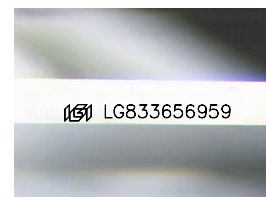


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

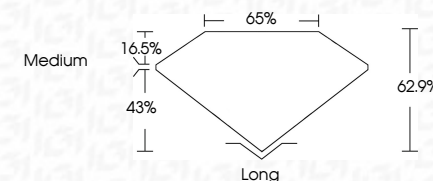
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www.igi.org

September 9, 2026
GJ Report No | G833656959

GI Report No 1280355699 GENERAL CUT 6.65 X 4.77 X 3.00 MM	1.00 CARAT F VVS 2 62.9% 65% Medium	Long EXCELLENT EXCELLENT NONE Colorless
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